Attorney's Docket No.: 14225-049001 / F1040149US00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kiyoshi Mita Art Unit: 2815

Serial No.: 10/813,782 Examiner: Chris C. Chu

Filed: March 31, 2004 Conf. No.: 5223

Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE

SAME

MAIL STOP RCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature, if any, are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

Listed reference AA (USPN 6,720,209) is the corresponding English reference for foreign listed reference AF (KR 10-2002-0033938).

This filing is being made with the filing of a Request for Continued Examination. No fee is required. However, please apply any charges or credits to deposit account 06 1050.

Respectfully submitted,

Date:	9/21/06	A
		Camara 1 Dana da ah

Samuel Borodach Reg. No. 38,388

Fish & Richardson P.C.
Citigroup Center
52nd Floor
153 East 53rd Street

New York, New York 10022-4611 Telephone: (212) 765-5070

Facsimile: (212) 258-2291

30301898.doc

Sheet	1	of	1
)11CCC		O1	

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 14225-049001	Application No. 10/813,782
1	closure Statement	Applicant Kiyoshi Mita	
(Use several sheets if necessary)		Filing Date	Group Art Unit
(37 CFR \$1.98(b))		March 31, 2004	2815

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	6,720,209	04/13/2004	Igarashi et al.			
	AB						
	AC						
	AD						
	AE						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner	Desig.	Document	Publication	Country or				slation
Initial	D	Number	Date	Patent Office	Class	Subclass	Yes	No
1.11	AF	KR-10-2002- 0033938	12/31/2002	Korea				x
	AG		5					
	AH							
	AI							
	AJ							

Other Documents (include Author, Title, Date, and Place of Publication)				
Examiner Initial	Desig. ID	Document		
	AK			
	AL			
	AM			
	AN			
	AO			
	AP			
	AQ			

Examiner Signature	Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.